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Recombination activity of light-activated copper defects in \( p \)-type silicon studied by injection- and temperature-dependent lifetime spectroscopy

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The presence of copper contamination is known to cause strong light-induced degradation (Cu-LID) in silicon. In this paper, we parametrize the recombination activity of light-activated copper defects in terms of Shockley—Read—Hall recombination statistics through injection- and temperature dependent lifetime spectroscopy (TDLS) performed on deliberately contaminated float zone silicon wafers. We obtain an accurate fit of the experimental data via two non-interacting energy levels, i.e., a deep recombination center featuring an energy level at \( E_c - E_t = 0.48 - 0.62 \) eV with a moderate donor-like capture asymmetry \((k = 1.7 - 2.6)\) and an additional shallow energy state located at \( E_c - E_t = 0.1 - 0.2 \) eV, which mostly affects the carrier lifetime only at high-injection conditions. Besides confirming these defect parameters, TDLS measurements also indicate a power-law temperature dependence of the capture cross sections associated with the deep energy state. Eventually, we compare these results with the available literature data, and we find that the formation of copper precipitates is the probable root cause behind Cu-LID. Published by AIP Publishing.

I. INTRODUCTION

Light-induced degradation (LID) is a current topic in silicon photovoltaics research due to its deleterious impact on solar cell efficiency upon exposure to illumination. This phenomenon has been traditionally ascribed to the formation of metastable boron-oxygen (B-O) complexes, whose composition has been intensively debated in the literature.¹,² However, recent results that showed severe LID in solar cells fabricated from multicrystalline silicon wafers with low bulk oxygen content have raised numerous discussions on alternative defect reactions, which might explain the observed degradation process. Low levels of copper contamination have been recently shown to cause a similar LID effect in both mono-⁵ and multi crystalline silicon.⁶,⁷ This phenomenon is referred to as copper-related light-induced degradation (Cu-LID), and it has been suggested to arise from increased bulk recombination⁸–¹⁰ caused by copper precipitation¹¹,¹² or substitutional copper complexes.¹³–¹⁵ Nevertheless, the recombination mechanisms at Cu-LID defects still remain unclear, and the current literature information is lacking in an accurate parametrization of the recombination activity of such defects. Therefore, it is important to determine the recombination parameters of Cu-LID defects in order to quantify their effect on minority carrier lifetime and predict their impact on the overall solar-cell performance.

Lifetime spectroscopy (LS) has been proposed in the literature as an effective approach to characterize electrically active defects through standard minority carrier lifetime measurements.¹⁶,¹⁷ LS techniques are based on the analysis of the injection- and temperature dependence of the minority carrier lifetime in terms of Shockley—Read—Hall (SRH) recombination statistics,¹⁸,¹⁹ such that the recombination parameters of the lifetime-limiting defect can be directly determined from least-squares fits to the experimental data. Since carrier lifetime is one of the most sensitive parameters to the presence of electrically active defects, LS methods enable the characterization of recombination active defects with concentrations well below the detection limit of other well-established characterization techniques, e.g., deep level transient spectroscopy (DLTS).

This paper aims at gaining a deeper insight into the recombination activity of the defect behind Cu-LID and the associated recombination phenomena. In this contribution, we apply LS methods to determine the SRH recombination parameters of light-activated Cu defects in deliberately contaminated float zone silicon (FZ-Si) wafers, which are free of B-O recombination due to the low bulk oxygen concentration. Since SRH parameters represent a typical fingerprint of the underlying recombination active defect, the extracted defect parameters have been compared with literature data, in order to correlate the LS results with the existing information on electrically active copper complexes.

II. EXPERIMENTAL

A. Sample preparation

The experiments were conducted on B-doped, 4-in., [100]-oriented FZ-Si wafers with the thickness of 280 \( \mu m \) and resistivity of 0.9, 3.4, and 18.4 \( \Omega \cdot cm \). After standard RCA-1 and RCA-2 cleanings, the wafer surfaces were passivated by growing a 15 nm thick thermal oxide layer, which was formed during 40 min of dry oxidation at 900 °C followed by annealing in nitrogen ambient at the same temperature for 20 min. Some wafers were then kept as reference samples, while the rest of the batch was subjected to intentional copper...

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contamination, performed by spinning a 1 ppm copper sulfate solution and subsequently annealing the samples in a nitrogen atmosphere at 800 °C for 20 min. This procedure resulted in bulk interstitial copper contamination, whose concentration is estimated to be in the range of 10¹⁴ cm⁻³. Next, an external corona charge was deposited on both wafer sides (+0.3 µC/cm²) to prevent Cu out-diffusion and decrease the surface minority carrier recombination through the formation of an inversion layer near the surface. The samples were then exposed to room temperature illumination under a 0.5 Sun LED lamp for up to 130 h in order to induce LID until the achievement of complete lifetime saturation. During light soaking, the lifetime decay caused by Cu-LID was constantly recorded as a function of illumination time through automated quasi-steady state photoconductance decay (QSSPC) measurements.

B. Injection and temperature-dependent lifetime measurements

Minority carrier lifetime measurements were performed by means of a Sinton WCT 120-TS tester, which allows injection-dependent QSSPC lifetime measurements at temperatures between 20 °C and 200 °C. The measurement setup consists of an inductive RF coil incorporated within a thermocouple-controlled measurement stage. Temperature-dependent measurements were performed by initially heating the measurement stage up to the maximum temperature and subsequently measuring the lifetime after predefined temperature steps of the cooling transient. Since carrier mobility strongly depends on the temperature, a correction based on Dorkel–Leturcq’s mobility model was applied to ensure the optimal calibration of the instrument over the whole temperature range. Furthermore, as the QSSPC technique is prone to trapping artifacts at low injection conditions, measurement points featuring abnormal lifetime increase at excess carrier concentrations below 10¹⁴ cm⁻³ were excluded from the analysis of the experimental data.

III. MODELING OF THE EXPERIMENTAL DATA

The SRH theory provides a well-established statistical model for describing charge carrier recombination at single energy levels within the bandgap, and it constitutes the conceptual framework behind lifetime spectroscopy methods. The determination of defect parameters through lifetime spectroscopy is thus performed under the assumption that the unknown recombination active defect introduces discrete energy levels. Supposing negligible trapping and, hence, equal excess electron and hole concentration (Δn = Δp), the SRH lifetime τSRH associated with a single-level defect is given by the following well-known equation:

\[
\tau_{SRH}(\Delta n, T) = \frac{\tau_{n0}(p_0 + p_1 + \Delta n) + \tau_{p0}(n_0 + n_1 + \Delta n)}{p_0 + n_0 + \Delta n},
\]

where \(n_0\) and \(p_0\), respectively, represent the equilibrium electron and hole concentrations and the capture time constants \(\tau_{n0}\) and \(\tau_{p0}\) are related to the defect density \(N_r\), the thermal velocity \(v_{th}\), and the electron and hole capture cross sections \(\sigma_n\) and \(\sigma_p\) via \(\tau_{n0} = (N_{vth} \sigma_n)^{-1}\) and \(\tau_{p0} = (N_{vth} \sigma_p)^{-1}\). The quantities \(n_1\) and \(p_1\) are often referred to as SRH densities and represent the electron and hole concentrations when the defect energy level \(E_r\) coincides with the Fermi level, i.e.,

\[
\begin{align*}
n_1(E_r, T) &= N_c \exp \left( \frac{E_c - E_r}{kT} \right) \\
p_1(E_r, T) &= N_v \exp \left( \frac{E_v - E_r}{kT} \right),
\end{align*}
\]

where \(E_c\) and \(E_v\) are the energetic positions of the conduction and valence bands and \(N_c\) and \(N_v\) are the effective densities of states in the conduction and valence bands, respectively. The recombination center is, thus, defined via three fundamental parameters, i.e., \(\tau_{n0}\), \(\tau_{p0}\), and \(E_r\), which must be simultaneously fitted from the injection and temperature-dependent experimental data. When the effect of two or more energy levels is taken into account, the total SRH lifetime is calculated as a reciprocal sum of the inverse lifetimes given by each recombination center.

The injection-dependent lifetime spectroscopy (IDLS) consists of the determination of the defect parameters by fitting Eq. (1) to the injection-dependent lifetime curves. Since the IDLS alone often yields ambiguous results, the analysis must be complemented with the temperature-dependent lifetime spectroscopy (TDLS). In this case, Eq. (1) is fitted to the temperature-dependent lifetime data measured at fixed injection level. The major contribution to the overall temperature dependence arises from the exponential dependence of \(n_1\) and \(p_1\). However, since Eq. (2) includes the state density \(N_c\) and \(N_v\), the variation of these two parameters as a function of temperature must also be taken into account, i.e.,

\[
\begin{align*}
N_c(T) &= N_c^{300K} \left( \frac{T}{300 K} \right)^{1.5} \\
N_v(T) &= N_v^{300K} \left( \frac{T}{300 K} \right)^{1.5},
\end{align*}
\]

where the effective densities of states are taken as \(N_c^{300K} = 2.86 \times 10^{19} \text{ cm}^{-3}\) and \(N_v^{300K} = 3.1 \times 10^{19} \text{ cm}^{-3}\). Additional temperature-dependence is imposed by the capture time constants \(\tau_{n0}\) and \(\tau_{p0}\) via the capture cross sections \(\sigma_n\) and \(\sigma_p\), whose variation mainly depends on the recombination mechanisms at the defect, and the carrier thermal velocity \(v_{th}\), which has been parametrized as follows:

\[
v_{th}(T) = v_{th}^{300K} \left( \frac{T}{300 K} \right)^{0.5}
\]

with \(v_{th}^{300K} = 1.1 \times 10^7 \text{ cm/s}\) being the thermal velocity of carriers at 300 K. As a first approximation, \(\sigma_n\) and \(\sigma_p\) are assumed to be temperature independent. Since a single set of defect parameters must provide an optimum fit to all the temperature- and injection-dependent lifetime curves, the temperature-dependence of \(\sigma_n\) and \(\sigma_p\) has been subsequently introduced in order to resolve possible inconsistencies between the fit results obtained from IDLS and TDLS analyses.
IV. RESULTS

A. Degradation process and determination of Cu-related lifetime

Figure 1 presents the effective lifetime measured during room-temperature illumination in an intentionally Cu-contaminated 3.4 Ω·cm FZ sample. The absence of LID in the reference sample indicates that the lifetime decay observed with intentionally contaminated specimens is solely caused by copper impurities. The Cu-related degradation process in FZ-Si occurs via a single asymptotical degradation process, which leads to complete lifetime saturation after at least 50 h of uninterrupted illumination. In this work, defect characterization has been carried out after complete lifetime saturation, such that the characterization of the defect is performed during its most harmful and recombination active state.

In order to obtain reliable spectroscopic results, the bulk lifetime limited by recombination at copper defects must always be separated from the effect of other recombination mechanisms, e.g., Auger, radiative, and surface recombination. Since no LID is observed in the reference sample, it can be reasonably assumed that light soaking solely activates Cu-LID defects while leaving the other recombination mechanisms unchanged. Therefore, the effective Cu-related lifetime ($\tau_{\text{Cu-eff}}$) can be calculated as follows:

$$\tau_{\text{Cu-eff}} = \left( \frac{1}{\tau_{\text{Cu-deg}}} - \frac{1}{\tau_{\text{ref}}} \right)^{-1},$$

where $\tau_{\text{Cu-deg}}$ and $\tau_{\text{ref}}$ are the minority carrier lifetimes measured after light soaking in the intentionally Cu-contaminated and the clean reference sample, respectively.

Figure 2 shows the lifetime values of $\tau_{\text{Cu-deg}}$, $\tau_{\text{ref}}$, and $\tau_{\text{Cu-eff}}$ plotted against the excess carrier densities. The superposition of the curves representing $\tau_{\text{Cu-deg}}$ and $\tau_{\text{Cu-eff}}$ over a broad injection range proves that the measured lifetime is largely dominated by carrier recombination through light-activated copper defects. Note that, in Eq. (5), the lifetime measured before illumination $\tau_{\text{init}}$ can, in principle, be used in lieu of $\tau_{\text{ref}}$ for the determination of the effective Cu-related lifetime. The figure also displays the Cu-related lifetime calculated by means of $\tau_{\text{init}}$ and $\tau_{\text{ref}}$. Despite the slight shift between $\tau_{\text{init}}$ and $\tau_{\text{ref}}$, which is probably caused by the effect of the contamination procedure on surface and Auger recombination, the superposition of the lifetime curves obtained from these two methods indicates that both of them can be used to determine the actual Cu-related lifetime. Since the latter approach would require the accurate measurement of $\tau_{\text{init}}$ at varying temperatures, which may turn interstitial copper into a recombination active state before light soaking,9,13,24 in this work, $\tau_{\text{Cu}}$ has been calculated by compensating the lifetime measured after degradation with temperature-dependent lifetime data obtained from a separate non-contaminated reference specimen.

B. Parametrization of the Cu-related lifetime in terms of SRH statistics

Figure 3 shows the injection-dependent lifetime curves in the temperature range from 25 to 195 °C and the corresponding SRH fit to the measured lifetime data. The SRH fit of the entire set of injection- and temperature-dependent lifetime curves requires the assumption of two non-interacting energy states, i.e., a deep recombination center, which mostly dominates the lifetime curve at a low injection level, and an additional shallow energy level affecting the carrier lifetime only at high injection conditions.

Since the coexistence of two defect centers unavoidably increases the number of parameters that must be simultaneously determined from each fit, the fit procedure was divided into several steps. As it will be discussed below in Fig. 4, the optimum fit of the low-injection part of each lifetime curve is achieved through a wide range of the defect parameters associated with the deep recombination center. Therefore, in an initial step, the defect parameters of the
shallow recombination center were initially optimized to fit the high injection part of the whole set of lifetime curves and the parameters associated with the deep level were arbitrarily chosen from the ranges that guarantee the optimum fit to the experimental data. Subsequently, the parameters of the shallow energy level were kept on fixed values \( E_c - E_t = 0.15 \text{ eV} \) with \( k = 0.1 \) and the true parameters associated with the deep recombination center were determined through the defect parameter solution surface (DPSS) method proposed by Rein et al.\(^{25,26}\) This approach consists of a fit routine which calculates the optimal fit values of the symmetry factor \( k = \frac{\tau_0}{\tau_\pi} = \frac{s}{p} \) and \( \tau_0 \), associated with the deep recombination center, while varying the values of the defect energy level \( E_t \) across the whole bandgap. Figure 4 shows an example of DPSS analysis applied to a single IDLS curve measured at room temperature, where the fitted \( k \)-factors are plotted together with the least-squares fit error for each energy level \( E_t \). It results clear that the analysis of a single injection-dependent lifetime curve leads to rather ambiguous fit results, as the least squares fit error is minimized by a broad range of different defect parameters. Such ambiguity can be overcome by extending the DPSS to the whole set of temperature-dependent lifetime curves and superposing the corresponding DPSS curves in the same graph, as shown in Figure 5(a). In this case, the optimal values of the defect parameters are identified by the convergence of all DPSS curves into a common intersection point. The displacement between the DPSS curves has been quantified in terms of relative standard deviation of the DPSS-\( k \) values at each energy level \( E_t \), which is plotted in Figure 5(b). The relative standard deviation presents two distinct minima located at \( E_c - E_t = 0.48 \pm 0.01 \text{ eV} \) and \( E_c - E_t = 0.62 \pm 0.02 \text{ eV} \). Hence, the large ambiguity arising from the SRH fit of a single IDLS curve results to be confined to a relatively narrow energy range located across the mid-bandgap, whose boundaries represent the optimal fit parameters. The minima of the calculated relative standard deviation also allow us to estimate the value of the symmetry factor, which results to be unambiguously determined as \( k = 1.7 \pm 0.4 \).

As discussed in Ref. 25, the superposition of all the temperature-dependent DPSS curves significantly reduces the ambiguity of the fit result obtained from a single IDLS curve. However, this method does not allow us to determine which of the two intersection points correspond to the exact defect parameters due to the reduced sharpness of the intersection.
points. This is probably a consequence of the fit errors, the moderate capture asymmetry of the defect which confines the possible solutions to a narrow range of values and the slight variation of $k$ across the temperature range imposed by the temperature-dependence of capture cross sections.

C. Temperature dependence of $\sigma_{n,p}$ and verification of LS results

In order to analyze the temperature dependence of capture cross sections and ascertain the validity of the previous spectroscopic results, the SRH model has been applied to the TDLS lifetime data. Figure 6(a) displays the temperature-dependent lifetime measured at the excess carrier density $\Delta n = 2 \times 10^{14}$ cm$^{-3}$, which corresponds to the lowest injection level at which the lifetime was reliably measured by the instrument across the temperature range. Since the shallow energy level has a negligible effect on the low-injection lifetime, the TDLS curve is fully described by a single SRH energy level. If capture cross sections are assumed to be time independent, the best fit is achieved with a defect located in the upper half of the bandgap with an energy level of $E_c - 0.13$ eV (Figure 6(b)).

However, the IDLS result in Figure 4 indicates that the energy level must lie deeper in the band gap to allow a simultaneous fit to the injection- and temperature-dependent lifetime data, such that the spectroscopic information gained under the assumption of temperature-independent capture cross sections has to be rejected for reasons of inconsistency. As can be seen from Figure 6(a), if the defect energy level is assumed to be located near the mid-bandgap, the supposition of temperature independent capture cross sections leads to the overestimation of the LLI lifetime at room temperature. This suggests that the SRH model must be complemented with an appropriate parametrization that accounts for the enlargement of $\sigma_{n,p}$ at decreasing temperatures. The optimum fit to the experimental data is obtained under the assumption of a power-law temperature dependence of the capture cross sections, i.e., $\sigma(T) = \sigma_0 \times T^{-z}$ with $z = 2.1$. The identified $\sigma(T)$ dependence will be further discussed in Sec. V.

Concerning the defect energy levels, the DPSS diagram in Figure 6(c) shows that the fitting error is minimized within the energy range between the conduction band edge and $E_c - 0.61$ eV, thus excluding most of the lower half of the bandgap from the possible energy levels associated with the deep recombination center. The domain of possible defect parameters that provide a consistent fit to both injection- and temperature-dependent curves is further restricted if the spectroscopic result from the IDLS curve in Figure 4 and the result of the TDLS analysis (Figure 6(c)) are superposed in the same graph, as indicated in Figure 7. The DPSS-k diagrams in Figure 7(a) show two specific intersection points located at $E_c - 0.49$ eV and $E_c - 0.61$ eV with a common symmetry factor $k = 2$, resulting in good agreement with the spectroscopic result that was previously discussed in Sec. IV B.
D. LS results obtained with different specimens

In order to cross-check the spectroscopic results obtained thus far, LS analyses have been applied to a set of FZ wafers with varying doping concentrations. For all samples, the SRH fit required the assumption of two independent recombination centers, one of them being a shallow energy state located between $E_c - 0.1$ eV and $E_c - 0.2$ eV with $k = 0.1$.

Concerning the deep recombination center, Table I summarizes the SRH parameters fitted from the lifetime data of all samples, and the SRH fit of the lifetime data obtained at room temperature is shown in Fig. 8. It is possible to notice that the spectroscopic analysis led to the identification of similar values for both $k$ and $E_c - E_f$, thus confirming the existence of energy states near the mid-bandgap with a moderate capture asymmetry. Furthermore, the SRH fit of all TDLS curves confirms the aforementioned $\sigma(T)^{-\alpha}$-dependence, which was modeled in terms of $\sigma(T) = \sigma_0 \times T^{-\alpha}$ with the exponent $\alpha$ varying between 1.2 and 2.1.

V. COMPARISON WITH LITERATURE DATA AND DISCUSSION

The spectroscopic analysis of the injection- and temperature-dependent lifetime data indicated the coexistence of at least two energy levels, i.e., a deep energy state located near the mid-bandgap and a shallow level in the upper bandgap half. Copper is known to give rise to a variety of substitutional copper defects ($\text{Cu}_i^+$) atoms and copper-boron ($\text{CuB}$) pairs are unlikely to affect the minority carrier lifetime, as no recombination activity has been related to such complexes. Moreover, the concentration of $\text{Cu}_i^+$ has been observed to decrease during illumination, thus indicating the transformation of $\text{Cu}_i^+$ into a different recombination-active defect. The formation of substitutional copper defects ($\text{Cu}_i$) during light-soaking has been intensively discussed in the literature. Early contributions attributed Cu-LID to the dissociation of a recombination inactive pure copper complex, which was long presumed to be $\text{Cu}_i\text{Cu}_i$ pair, and the subsequent formation of highly recombination active $\text{Cu}_i$ complexes. However, this reaction does not explain the aforementioned decrease of $\text{Cu}_i^+$ concentration during light-soaking. Moreover, DLTS studies on intentionally Cu contaminated material revealed the existence of two acceptor energy states located at $E_v + 0.41...0.45$ eV and $E_c - 0.16$ eV which were later associated with the substitutional copper defect. While the energy state at $E_c - 0.16$ eV seems to be in good agreement with LS results reported in this study, no strong evidence of the other energy states can be found. The acceptor-like behavior of the deep energy state at $E_v + 0.41...0.45$ eV would impose a large capture cross section for majority carriers, and hence $k \ll 1$, which is in disagreement with the spectroscopic result that was shown in Sections IV B and IV C. Furthermore, the energy level of this recombination center seems not to match the result of the TDLS fit and the temperature-dependent DPSS analysis (Figures 5 and 6(c)), which set the energy level at least 100 meV deeper into the bandgap.

Copper is also known to form electrically active copper silicides ($\eta'' - \text{Cu}_i\text{Si}$) stemming from the precipitation of $\text{Cu}_i^+$ atoms. Such extended defects introduce a continuous band of energy states in the upper half of the bandgap, from $E_v - 0.15$ eV to $E_v - (0.4...0.5)$ eV with an estimated electron capture cross-section $\sigma_n = 3 \times 10^{-16}$ cm$^2$, Macdonald et al. showed through LS methods that the impact of this distributed energy band can be approximated via two non-interacting SRH defects with energy levels located at $E_v - 0.15$ eV and $E_v - 0.58$ eV, which approximately correspond to the extremes of the aforementioned energy band. Though some uncertainty on the actual energy levels exists, the spectroscopic result obtained in this work appears to be in good agreement with the IDLS and TDLS analysis presented by Macdonald et al. for thermally induced Cu precipitates. Considering that Cu precipitates introduce a continuous band of energy states rather than individual states due to their extended nature, it must be pointed out that a rigorous study of carrier recombination through distributed energy states would require more complex recombination models. This may explain the slight displacement

<table>
<thead>
<tr>
<th>Resistivity [Ω-cm]</th>
<th>$\rho_0$ [cm$^{-1}$]</th>
<th>DPSS solution 1 $E_v - E_f$ [eV]</th>
<th>DPSS solution 2 $E_c - E_f$ [eV]</th>
<th>$\mu_{DPSS - 1/2}$</th>
<th>$\sigma(T)$</th>
</tr>
</thead>
<tbody>
<tr>
<td>0.9</td>
<td>$1.65 \times 10^{16}$</td>
<td>0.51 ± 0.02</td>
<td>0.61 ± 0.02</td>
<td>2.6 ± 0.4</td>
<td>$\propto T^{-1.2}$</td>
</tr>
<tr>
<td>3.4</td>
<td>$4 \times 10^{15}$</td>
<td>0.48 ± 0.01</td>
<td>0.62 ± 0.02</td>
<td>1.7 ± 0.4</td>
<td>$\propto T^{-2.1}$</td>
</tr>
<tr>
<td>18.4</td>
<td>$7.13 \times 10^{14}$</td>
<td>0.51 ± 0.03</td>
<td>0.59 ± 0.03</td>
<td>1.9 ± 0.3</td>
<td>$\propto T^{-1.9}$</td>
</tr>
</tbody>
</table>

FIG. 8. Injection dependent lifetime curves measured at room temperature in Cu-contaminated samples featuring different doping concentrations. The solid line represents the fit obtained with two non-interacting SRH levels (deep and shallow).
between the experimental data and the fitted SRH lifetime, which is visible in Figures 3 and 8. Nevertheless, the results shown in this contribution indicate that the description of the lifetime data via the assumption of single point-like SRH energy states still provides a satisfactory approximation of the underlying recombination activity over the measurable injection range.

Based on the above defect identification, it is possible to relate the recombination mechanisms at metal precipitates to the aforementioned $\sigma(T)$-dependence and speculate on the effect of the degradation conditions (e.g., light intensity or temperature during LID) on the recombination activity of such defects. The $\sigma(T)$-dependence described in Sec. IV C is likely to arise from the temperature dependence of the thermionic recombination currents at the Schottky junction formed near the precipitate-semiconductor interface.\(^{42}\) The aforementioned $\sigma(T)$-dependence has also been associated with the excitonic Auger capture process, which has been reported for defects introducing deep energy states.\(^{43}\)

In addition to the doping concentration, the degradation kinetics of Cu-LID have been found to significantly depend on other parameters, such as illumination intensity, temperature, and the presence of bulk defects (e.g., vacancies or dislocations).\(^{7,15}\) All these parameters are likely to affect the precipitate size distribution and, therefore, result in a different recombination activity of such defects. In addition to providing further evidence of the existence of such precipitates, advanced recombination models that correlate the injection-dependent lifetime with the precipitate radius\(^{44}\) may also provide additional information on the formation mechanisms.

**VI. CONCLUSION**

In this work, injection- and temperature-dependent lifetime spectroscopy analysis has been applied to intentionally Cu-contaminated $p$-type FZ silicon for characterizing the recombination activity of the defects activated under room-temperature illumination. In order to verify the accuracy and repeatability of the spectroscopic result, the analysis has been applied to a set of similarly processed wafers of different resistivities. For all samples, IDLS and TDLS methods revealed that the recombination activity of light-activated copper defects is well described by two non-interacting levels, i.e., a shallow energy level at $E_c - E_F = 0.1 - 0.2 \text{ eV}$ and a deep recombination center at $E_c - E_F = 0.48 - 0.51 \text{ eV}$ or $E_v - E_F = 0.59 - 0.62 \text{ eV}$ with $k$ varying between 1.7 and 2.6 and a strong power-law temperature dependence of the capture cross sections. The defect energy levels coincide with the edges of the energy band associated with Cu-precipitates, thus indicating this defect as the possible culprit behind the observed LID process. Since lifetime spectroscopy methods are mostly sensitive to the defects that impact the recombination lifetime to a greater extent, the result shown in this work does not rule out the coexistence of other less-recombination active defects, which might be pinpointed by DLTS measurements.

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